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This is a request for filing a U.S. Patent Application claiming priority, under 35 U.S.C. §120, from US Application 09/665,544, filed on September 19, 2001.

Pages

Applicant:

James W. Overbeck

Title:

WIDE FIELD OF VIEW AND HIGH SPEED SCANNING MICROSCOPY

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This application is a continuation (and claims priority under 35 U.S.C. §120) of US Application 09/665,544, filed on September 19, 2001, which is a continuation of PCT Application PCT/US99/06097 filed on March 19, 1999; a continuation-in-part of US Application Ser. No. 09/170,847, filed on October 13, 1998; and a continuation-in-part of US Application Ser. No. 09/045,547, filed on March 20, 1998. The disclosure of the above-mentioned applications is considered part of, and is incorporated by reference in, the disclosure of this application.

Kindly acknowledge receipt of this application by returning the enclosed postcard.

Respectfully submitted,

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